



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/695,381 **Confirmation No.:** 5308

Applicants: Jene A. Golovchenko et al.

Filed: October 28, 2003

TC/A.U.: 1753

Examiner: S. H. Versteeg

Docket No.: HVD2105

For: Pulsed Ion Beam Control of Solid State Features

MAIL STOP RCE
COMMISSIONER FOR PATENTS
P. O. BOX 1450
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I hereby certify that this correspondence is being deposited on the date shown below with the United States Postal Service with sufficient postage as first class mail, under 37 CFR 1.8(a), in an envelope addressed to: Mail Stop Amendment, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Shirley A. Pler
March 2, 2006

RESPONSE AND AMENDMENT

This is in response to the Examiner's Action mailed October 4, 2005. The response indicated a shortened statutory period for reply of two months or thirty days, whichever is longer, from the mailing date of the communication, setting the end of the period for reply at December 4, 2005. Therefore, a petition for a three-month extension of time to the shortened statutory period for reply accompanies this response.

Please amend the above-identified application as follows:

Amendment to the Specification begins on Page 2 of this paper.

Remarks begin on page 3 of this paper.